

## AMENDMENTS TO THE CLAIMS

1 (currently amended) A method for manufacturing a monolithic piezoelectric part which has a plurality of piezoelectric ceramic layers and spaced internal electrode layers disposed in said piezoelectric ceramic part, wherein said piezoelectric ceramic making up said piezoelectric ceramic layers is formed of a perovskite compound oxide expressed by the general formula of  $ABO_3$ , and comprises at least Pb for the A site component and at least comprises Ti or Ti and Zr for the B site component; said method comprising:

providing a piezoelectric ceramic powdered raw material wherein the molar quantity of said A site component is reduced by about 0.5 mol% to 5.0 mol% from that of a stoichiometric composition and the average valence of said B site component of the ceramic raw material is greater than that of the stoichiometric composition and is greater than 4.000 and less than 4.100;

fabricating a layered article with said piezoelectric ceramic powdered raw material; and

sintering ~~step~~ said layered article within an atmosphere wherein the oxygen concentration is about 5% by volume or less but more than 0% by volume.

2 - 3 (canceled)

4 (currently amended). A method for manufacturing a monolithic piezoelectric part according to Claim [[3]] 1, wherein the molar quantity of Pb included in said A site component has been reduced by about 0.5 mol% to 5.0 mol% from that of the stoichiometric composition.

5 (original). A method for manufacturing a monolithic piezoelectric part according to Claim 4, wherein said B site component further comprises Nb.

6 (original). A method for manufacturing a monolithic piezoelectric part according to Claim 4, wherein said B site component further comprises Nb and Ni.

7 (original). A method for manufacturing a monolithic piezoelectric part according to Claim 4, wherein said B site component further comprises at least one of Nb, Sb, Ta and W.

8 (original). A method for manufacturing a monolithic piezoelectric part according to Claim 7, wherein said B site component further comprises at least one of Ni, Cr, Co and Mg.

9 (original). A method for manufacturing a monolithic piezoelectric part according to Claim 8, wherein said layered article fabrication comprises a ceramic green sheet fabrication forming said piezoelectric ceramic powdered raw material into sheet form so as to fabricate a plurality of ceramic green sheets, forming an electrode pattern on at least two of said ceramic green sheets with an electroconductive paste for internal electrodes, and layering a plurality of ceramic green sheets upon which said electrode patterns have been formed so as to form a layered article.

10 (original). A method for manufacturing a monolithic piezoelectric part according to Claim 9, wherein said electroconductive paste contains Ag as a primary component.

11 (original). A method for manufacturing a monolithic piezoelectric part according to Claim 10, wherein said electroconductive paste contains Ag and Pd in a ratio of at least 70/30.

12 (currently amended). A method for manufacturing a monolithic piezoelectric part according to Claim 11, wherein said electroconductive paste contains Ag and Pd in a ratio of at least 80/20 and the thickness of the ceramic layers is such that their thickness after sintering is about 64µm or less.

13 (currently amended). A method for manufacturing a monolithic piezoelectric part according to Claim 12, wherein said electroconductive paste contains Ag and Pd in a ratio of at least 85/15 and the thickness of the ceramic layers is such that their thickness after sintering is about 40µm or less.

14 (currently amended). A method for manufacturing a monolithic piezoelectric part according to Claim 1, wherein said B site component further ~~comprises~~ comprises Ti and Zr; ~~and wherein the average valence of said B site component is greater than 4.000 and less than 4.100.~~

15 (original). A method for manufacturing a monolithic piezoelectric part according to Claim 1, wherein said B site component further comprises Nb.

16 (original). A method for manufacturing a monolithic piezoelectric part according to Claim 1, wherein said layered article fabrication comprises a ceramic green sheet fabrication forming said piezoelectric ceramic powdered raw material into sheet form so as to fabricate a plurality of ceramic green sheets, forming an electrode pattern on at least two of said ceramic green sheets with an electroconductive paste for internal electrodes, and layering a plurality of ceramic green sheets upon which said electrode patterns have been formed so as to form a layered article.

17 (original). A method for manufacturing a monolithic piezoelectric part according to Claim 16, wherein said electroconductive paste contains Ag as a primary component.

18 – 20 (canceled)

21 (New) A method for manufacturing a monolithic piezoelectric part according to Claim 1, wherein said B site component further comprises Nb and Ni.